

Absolute Pressure Sensor (0-20 BAR)



- 0 to 2000kPa pressure range 20bar or 300PSI)
- Absolute pressure sensor
- Silicon/Grass Bonding wafer, high stability
- Miniature surface mount
- RoHS-compatible & Pb-free
- Provide the other gage pressure range sensor

DESCRIPTION

The Series of pressure sensor is a silicon micro-machined membrane, piezo-resistive sensor. They were designed for extremely cost sensitive applications where the sensing element is to be integral to the OEM equipment, and are intended for use with non-corrosive, non-ionic media. They also may be packaged with application specific sensor die so that the performance characteristics and output range also can be identified.

FEATURES

- Uncompensated pressure sensor
- Temperature Range -40°C ~ +125°C
- Low Cost, High reliability

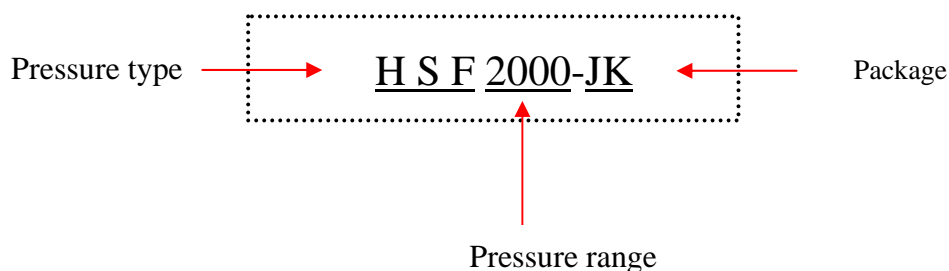
APPLICATION

- For high resolution absolute sensor systems
- Engine Controls
- Barometers, Altimeters, Variometers

Full Scale Pressure

kPa	bar	mbar	PSI	atm	mmHg	mmH ₂ O	kg/cm ²
100	1	1000	15	1	750	10207	1

Part number System



Characteristics

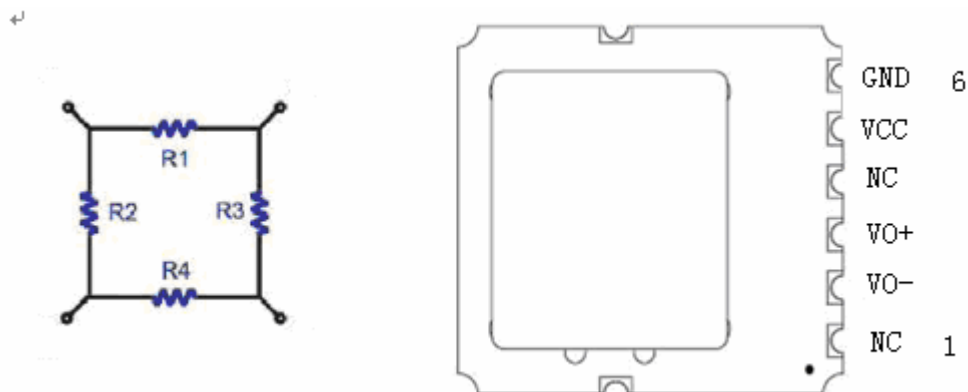
Working conditions: DC @ 5v, Pressure 2000KP, temperature 25 °C ,
humidity at 30% -90%

项目	最小值	标准值	最大值	单位
Pressure range		300PSI		
Supply voltage	0	5.0	10.0	Volts
Currency	0	1.5	3.0	mA
Span	60	100	140	mV
Offset	-30	0	30	mV
Temperature coefficient	-16	-22	-28	%FS/100°C
Temperature coefficient of zero	-4	-6	-8	%FS/100°C
Nonlinearity	0	0.1	0.5	%F.S
Bridge resistance	4	5	6	KΩ
Proof pressure			2×	满量程
Operating temperature	-40		125	°C
Storage temperature	-40		125	°C

WAFER ELECTRICAL CONNECTIONS

1. Best fit straight line.
2. Coefficients are typical values between -10°C and 40°C.

Pin Configuration



PAD	1	2	3	4	5	6
Definition	NC	VO-	VO+	NC	VCC	GND

